

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:				
Tae-Eun PARK				
Applica	ation No.:	10/767,742	Group Art Unit No.:	3661
Filed:		January 30, 2004	Examiner	Unassigned
Customer No.:		38209	Confirmation No.	5722
For:		AGV CONTROL SYSTEM AND METHOD		
		INFORMATION DISCLOSURE STATEMENT		
Assistant Commissioner for Patents Washington, D.C. 20231				
Sir:			•	
In accordance with the duty of disclosure provisions of 37 CFR § 1.56, there is hereby provided certain information which the Examiner may consider material to the examination of the subject U.S. patent application. It is requested that the Examiner make this information of record if it is deemed material to the examination of the subject application.				
1. Enclosures accompanying this Information Disclosure Statement are:				
	1a.	 Copies of IDS citations. A copy of a communication from a counterpart foreign International Search Report. English language translation (abstracts only) attached language publication. 		to each non-English ENT 1(e), hereto) for publication.
2. 🛛	This Information Disclosure Statement is filed under 37 CFR §1.97(b):		97(b):	
	2a. 🗌 2b. 🗍	(Check either Item 2a Within three months of the filing Continued Prosecution Applicati Within three months of the date §1.491 in an international applic	date of a national app on under §1.53(d); of entry of the nationa	



Attorney Docket No.: 103-1003



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Tae Eun PARK

Application

10/767,742

Group Art Unit:

3661

Filed:

April 12, 2004

Examiner

Cuong H. Nguyen

Customer No.:

38209

Confirmation No.

5722

For:

AGV CONTROL SYSTEM AND METHOD

COMMUNICATION REGARDING IDS REFERENCES

BOX: Issue Fee

Commissioner for Patents Alexandria, VA 22313

Sir:

Applicant respectfully requests indication that the co-pending U.S. applications cited in the Information Disclosure Statement filed on January 25, 2007 have been considered. Attached is a copy of the Information Disclosure Statement as filed on January 25, 2007 for the Examiner's convenience.

Respectfully submitted,

NZIONE & KIM, LLP

Date: July 24,2007

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